S/N 09/940917

**PATENT** 

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Gurtej S. Sandhu et al.

Examiner: Jeff Vockrodt

RADSerial No.:

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Group Art Unit: 2822

Filed:

August 28, 2001

Docket No.: 303.676US2

Title:

CHEMICAL VAPOR DEPOSITION OF TITANIUM

## **AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111**

13/D Andt 9.16.03 A.Wash

Commissioner for Patents P.O.Box 1450 Alexandria, VA 22313-1450

Applicant has reviewed the Office Action mailed on June 5, 2003. Please amend the above-identified patent application as follows.

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